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Please find below and/or attached an Office communication concerning this application or proceeding.

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| | Application No. | Applicant(s) |
| Office Action Commence | 10/674,873 | LOGSDON ET AL. |
| Office Action Summary | Examiner | Art Unit |
| | Paul L Rodriguez | 2125 |
| The MAILING DATE of this communication app Period for Reply | ears on the cover sheet with the c | orrespondence address |
| A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b). | 36(a). In no event, however, may a reply be time within the statutory minimum of thirty (30) day will apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE | nely filed s will be considered timely. the mailing date of this communication. D (35 U.S.C. § 133). |
| Status | | |
| 1) Responsive to communication(s) filed on 2a) This action is FINAL. 2b) This 3) Since this application is in condition for allowar closed in accordance with the practice under E | action is non-final. nce except for formal matters, pro | |
| Disposition of Claims | | |
| 4) ☐ Claim(s) 1-26 is/are pending in the application. 4a) Of the above claim(s) is/are withdray 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) 1-26 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and/or | vn from consideration. | |
| Application Papers | | |
| 9) The specification is objected to by the Examine 10) The drawing(s) filed on 26 February 2004 is/are Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the Ex | e: a) ☐ accepted or b) ☒ objecte drawing(s) be held in abeyance. Ser ion is required if the drawing(s) is ob | e 37 CFR 1.85(a). jected to. See 37 CFR 1.121(d). |
| Priority under 35 U.S.C. § 119 | | |
| 12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority document: 2. Certified copies of the priority document: 3. Copies of the certified copies of the priority document: application from the International Bureau * See the attached detailed Office action for a list | s have been received. s have been received in Applicati rity documents have been receive u (PCT Rule 17.2(a)). | on No ed in this National Stage |
| Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date | 4) Interview Summary Paper No(s)/Mail Di 5) Notice of Informal F 6) Other: | |

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DETAILED ACTION

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1. Claims 1-26 are presented for examination.

Drawings

- 2. The drawings are objected to as failing to comply with 37 CFR 1.84(p)(5) because they do not include the following reference sign(s) mentioned in the description: 352, 452. Corrected drawing sheets in compliance with 37 CFR 1.121(d) are required in reply to the Office action to avoid abandonment of the application. Any amended replacement drawing sheet should include all of the figures appearing on the immediate prior version of the sheet, even if only one figure is being amended. The replacement sheet(s) should be labeled "Replacement Sheet" in the page header (as per 37 CFR 1.84(c)) so as not to obstruct any portion of the drawing figures. If the changes are not accepted by the examiner, the applicant will be notified and informed of any required corrective action in the next Office action. The objection to the drawings will not be held in abeyance.
- 3. The drawings are objected to as failing to comply with 37 CFR 1.84(p)(5) because they include the following reference character(s) not mentioned in the description: 52 (figure 3B and 4B), 376. Corrected drawing sheets in compliance with 37 CFR 1.121(d), or amendment to the specification to add the reference character(s) in the description in compliance with 37 CFR 1.121(b) are required in reply to the Office action to avoid abandonment of the application. Any amended replacement drawing sheet should include all of the figures appearing on the immediate prior version of the sheet, even if only one figure is being amended. The replacement sheet(s) should be labeled "Replacement Sheet" in the page header (as per 37 CFR 1.84(c)) so as not to

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obstruct any portion of the drawing figures. If the changes are not accepted by the examiner, the applicant will be notified and informed of any required corrective action in the next Office action.

The objection to the drawings will not be held in abeyance.

4. The examiner has provided a number of examples of the drawing deficiencies in the above, however, the list of deficiencies may not be all inclusive. Applicant should refer to these as examples of deficiencies and should make all the necessary corrections to eliminate the drawing objections.

Specification

5. Applicant is reminded of the proper language and format for an abstract of the disclosure.

The abstract should be in narrative form and generally limited to a single paragraph on a separate sheet within the range of 50 to 150 words. It is important that the abstract not exceed 150 words in length since the space provided for the abstract on the computer tape used by the printer is limited. The form and legal phraseology often used in patent claims, such as "means" and "said," should be avoided. The abstract should describe the disclosure sufficiently to assist readers in deciding whether there is a need for consulting the full patent text for details.

The language should be clear and concise and should not repeat information given in the title. It should avoid using phrases which can be implied, such as, "The disclosure concerns," "The disclosure defined by this invention," "The disclosure describes," etc.

The abstract of the disclosure is objected to because it contains a number of words in excess of 150 words. Correction is required. See MPEP § 608.01(b).

6. The disclosure is objected to because of the following informalities:

Page 12 lines 10-14 refers to reference number 208a as without crosshatches and 208b with crosshatches, figure 2A-1 shows both 208a and 208b without crosshatches.

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Page 12 lines 19-20 states "210a, with crosshatches", figure 2A-2 shows no crosshatches.

Page 12 line 21 states "lightly shaded objects, such as object 210b", reference number 210b has no shading present.

Page 12 line 22 – page 13 line 1 states "the darker shaded objects, such as object 210c", reference number 210c has no shading.

Page 14 line 3 states "212b, with lighter shading", figure 2A-2 shows no shading for 212b. Page 14 line 5 states "212c, with darker shading", figure 2A-2 shows no shading for 212c. Appropriate correction is required.

7. The examiner has provided a number of examples of the specification deficiencies in the above, however, the list of deficiencies may not be all inclusive. Applicant should refer to these as examples of deficiencies and should make all the necessary corrections to eliminate the specification objections.

Claim Objections

8. Claims 1 and 12 are objected to because of the following informalities:

Claim 1 line 20 refers to "the at least one resource", previously "a plurality of resources", "the resource", "at least some of the resources" and "at least one of the resources" (plural).

References to the same limitations should remain consistent to avoid any possible confusion in the claim.

Claim 12 line 6 refers to "the one or more items identified", previously "resources and flow" where "identified", unclear if this is what the claim is referring to, could create an antecedent problem in the claim.

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Appropriate correction is required.

9. The examiner has provided a number of examples of the claim deficiencies in the above, however, the list of deficiencies may not be all inclusive. Applicant should refer to these as examples of deficiencies and should make all the necessary corrections to eliminate the claim objections.

Claim Rejections - 35 USC § 112

- 10. The following is a quotation of the second paragraph of 35 U.S.C. 112:
 - The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.
- 11. Claims 1-19 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.
- 12. Claim 1 recites the limitation "the resources and flows" in lines 16-17. There is insufficient antecedent basis for this limitation in the claim.
- 13. Claim 6 recites the limitation "the first portion" in lines 1-2. There is insufficient antecedent basis for this limitation in the claim.
- 14. Claim 8 recites the limitation "the second portion" in lines 1-2. There is insufficient antecedent basis for this limitation in the claim.

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15. Claim 11 recites the limitation "the resources and flows" in lines 14-15. There is

insufficient antecedent basis for this limitation in the claim.

16. Claim 16 recites the limitation "the first portion" in line 1. There is insufficient antecedent

basis for this limitation in the claim.

17. Claim 18 recites the limitation "the second portion" in line 1. There is insufficient

antecedent basis for this limitation in the claim.

18. Due to the number of 35 USC § 112 second paragraph rejections, the examiner has

provided a number of examples of the claim deficiencies in the above rejection(s), however, the

list of rejections may not be all inclusive. Applicant should refer to these rejections as examples

of deficiencies and should make all the necessary corrections to eliminate the 35 USC § 112

second paragraph problems and place the claims in a proper format.

Claim Rejections - 35 USC § 101

19. 35 U.S.C. 101 reads as follows:

Whoever invents or discovers any new and useful process, machine, manufacture, or composition of matter, or any new and useful improvement thereof, may obtain a patent therefor, subject to the conditions and requirements of

this title.

Claims 11-19 are rejected under 35 U.S.C. 101 because the claimed invention is directed to

non-statutory subject matter. The method as recited is not technically embodied, the method can

be performed simply by a person acting as a resource allocator, by monitoring resources.

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Representation mathematically could be an abstract representation on paper where a person could provide mathematical indications of resource status and use those representations to assign tasks. The graphical user interface and virtual queue could again be an abstract representation on paper. The term virtual, by its nature is simply a representation of something that is not physically embodied, such as an image, picture or drawing can be considered virtual. Insertion of the phrase "computer implemented" into the preamble of the claim would render the claim statutory. A computer implemented method of..."

20. Due to the vagueness and a lack of a clear definition of the terminology and phrases used in the specification and claims, the claims have been treated on their merits as best understood by the examiner.

Claim Rejections - 35 USC § 103

- 21. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was

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made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

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22. Claims 1 and 11 are rejected under 35 U.S.C. 103(a) as being unpatentable over Bickley et al (U.S. Pat 6,615,092).

Bickley et al teaches a resource allocator (figure 3) and method (abstract) operable to allocate a plurality of resources among a plurality of tasks within a process system, the process system capable of executing at least one application process (col. 2 lines 37-65, col. 4 lines 43-67, col. 6 line 15 – col. 7 line 63), the resource allocator comprising a monitoring controller operable to monitor one or more characteristics associated with the at least one application process, the resources, and the tasks (col. 4 lines 52-55, col. 7 lines 30-45, col. 7 line 64 – col. 8 line 12), a model of the process system representing mathematically the resources and the tasks and defining relationships among related ones of the resources and the tasks as a function of the at least one application process (WIP profile, col. 4 lines 43-52, col. 10 lines 3-55, steps 508-514), a resource allocation controller operable to operate the model in response to ones of the monitored characteristics and allocate ones of the resources among ones of the tasks to execute the at least one application process (col. 2 lines 54-65, col. 8 lines 59-64), and a graphical user interface operable to identify the resources and flows between at least some of the resources (col. 2 lines 50-53, col. 3 lines 1-5, col. 9 lines 11-25, col. 10 lines 3-55, reference number 319-322, 403), the graphical user interface comprising at least one virtual queue associated with at least one of resources and identifying one or more items to be processed by the at least one resource (col. 6 line 61 – col. 7 line 7, col. 7 lines 19-23 "staged", col. 8 line 65 – col. 9 line 10 "reselect an allocated resource", col. 9 lines 27-40, col. 10 lines 40-43 "current volume scheduled"). Examiner would like to point out that any reference to specific figures, columns and lines should not be considered limiting in any way, the entire reference is considered to provide disclosure relating to the claimed invention.

Bickley et al fails to specifically teach a "virtual queue".

Examiner considers the term virtual queue to be supported by the user interface recited in Bickley et al, teaches updating the user interface in real time, teaches an automated storage and retrieval system 108 which can be considered a queue, teaches products being boxed or staged, which is considered queuing, teaches resources for storing which is part of the queuing process, teaches reallocating work that was already scheduled for processing, teaches remote monitoring system including a graphical illustration of each piece of equipment in the manufacturing facility and an associated status log for the equipment in col. 10 lines 3-19, and providing all of this information to a user in a real time display.

Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to utilize a "virtual queue" in the resource allocator of Bickley et al because a virtual queue is simply a graphical user representation of a queue, which the display of Bickley et al already provides.

23. Claims 20, 21, 23 are rejected under 35 U.S.C. 103(a) as being unpatentable over Lee (U.S. Pat 5,616,208) in view of Rangachari et al (U.S. Pat 6,470,227).

Lee teaches (claim 20) a computer program embodied on a computer readable medium and operable to be executed by a processor (col. 29 lines 12-17), the computer program comprising computer readable program code for generating a graphical user interface (col. 29 lines 18-23), and semiconductor wafer processing equipment consists of wet decks (table 3, col. 33 lines 24-30,

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col. 33 line 54 – col. 34 line 59) and one or more furnaces, the one more furnaces comprising at least one vertical polysilicon furnace (col. 33 lines 31-35).

Lee fails to teach (claim 20) the graphical user interface comprising a first portion identifying at least two types of semiconductor wafers to be processed by at least one of one or more semiconductor manufacturing equipment, a second portion identifying the one or more semiconductor manufacturing equipment and flows of semiconductor wafer lots between the one or more semiconductor manufacturing equipment, the second portion comprising at least one virtual queue operable to identify one or more semiconductor wafer lots to be processed by the at least one semiconductor manufacturing equipment, (claim 21) the virtual queue identifies a recipe associated with each semiconductor wafer lot, a number of semiconductor wafers in each semiconductor wafer lot, and a latest time when each semiconductor wafer lot should be provided to the at least one semiconductor manufacturing equipment, (claim 23) wherein the first portion comprises a plurality of buckets, each bucket associated with one type of semiconductor wafer to be processed by the semiconductor manufacturing equipment, each bucket identifying a plurality of time periods and a number of semiconductor wafers to be processed during each of the time periods.

Rangachari et al teaches (claim 20) a computer program embodied on a computer readable medium and operable to be executed by a processor (abstract, col. 5 lines 6-12, col. 6 lines 8-24), the computer program comprising computer readable program code for generating a graphical user interface (col. 6 lines 25-31, col. 7 lines 20-24), the graphical user interface comprising a first portion identifying at least two types of semiconductor wafers to be processed by at least one of one or semiconductor manufacturing equipment (figure 2, col. 9 lines 13-42), and a second portion identifying the semiconductor manufacturing equipment and flows of semiconductor wafer lots

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between the semiconductor manufacturing equipment (figure 4, col. 13 lines 4-12), the second portion comprising at least one virtual queue operable to identify one or more semiconductor wafer lots to be processed by the semiconductor manufacturing equipment (figure 4, col. 8 lines 23-29, col. 13 lines 4-41), (claim 21) wherein the virtual queue identifies a recipe associated with each semiconductor wafer lot, a number of semiconductor wafers in each semiconductor wafer lot, and a latest time when each semiconductor wafer lot should be provided to the semiconductor manufacturing equipment (col. 10 lines 13-42, col. 13 lines 16-41), (claim 23) wherein the first portion comprises a plurality of buckets (reference number 102), each bucket associated with one type of semiconductor wafer to be processed by the semiconductor manufacturing equipment, each bucket identifying a plurality of time periods and a number of semiconductor wafers to be processed during each of the time periods (col. 10 lines 9-26, col. 13 lines 16-41).

Lee and Rangachari et al are analogous art because they are both related to processing semiconductor wafers and each includes a user interface.

Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to utilize the Graphical User Interface of Rangachari et al in the control system including wet decks and a vertical polysilicon furnace of Lee because wet deck and vertical polysilicon furnaces are well known in the art of semiconductor wafer processing and Rangachari et al teaches a system that provides a quick means to configure new equipment and automates all types of equipment (col. 4 lines 36-50), can automate any microelectronic manufacturing process (col. 5 lines 50-64), speedy automation of equipment through the graphical user interface (col. 9 lines 3-9), automation for all types of equipment (col. 11 lines 48-65) and that the computer program of the present invention is expandable to provide software that includes monitoring and controlling temporary material storage (col. 16 lines 32-51, considered a queue).

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24. Claims 2, 3, 5, 6, 10, 12, 13, 15 and 16 are rejected under 35 U.S.C. 103(a) as being unpatentable over Lee (U.S. Pat 5,616,208) in view of Rangachari et al (U.S. Pat 6,470,227) as applied to claims 20, 21 and 23 above, and further in view of Bickley et al (U.S. Pat 6,615,092).

Lee as modified by Rangachari et al teaches a computer embodied program for generating a graphical user interface as recited in claims 20, 21 and 23 for the reasons above, differing from the invention as recited in claims 2, 3, 5, 6, 10, 12, 13, 15 and 16 in that their combined teaching lacks the resource allocator as recited in claim 1.

Bickley et al teaches the resource allocator as recited in claim 1.

Lee as modified by Rangachari et al and Bickley are analogous art because they are both related to manufacturing systems with user interfaces.

Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to utilize the resource allocator of Bickley et al in the graphical user interface of Lee as modified by Rangachari et al because Bickley et al teaches real time acquisition of work in process profiles to a control center to allow an operator to make timely decisions as to the reallocation of work improving throughput (col. 7 lines 30-45) and a greater number of carrier vehicles can be accommodated at one time making it possible for the manufacturer to increase production levels and to provide customers with products in a timely manner while utilizing the just-in-time approach to procuring material and provides for a work flow that is conducive to rapid production and space efficiency (col. 5 lines 41-63).

25. Claims 8, 9, 18, 19, 25 and 26 are rejected under 35 U.S.C. 103(a) as being unpatentable over Lee (U.S. Pat 5,616,208) in view of Rangachari et al (U.S. Pat 6,470,227) and Bickley et al

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(U.S. Pat 6,615,092).

Lee as modified by Rangachari et al and Bickley et al teaches a resource allocator with a graphical user interface as recited in claims 1-3, 5, 6, 10-13, 15 and 16 for the reasons above, the combination does not expressly teach the use of graphical user interface objects of different shapes, colors or shading to identify an object.

Official notice is taken that the use of different shapes, colors and shading used in Graphical User Interfaces was well known at the time the invention was made such as in the art of Hocker et al (U.S. Pat 5,754,179) which teaches the well known practice of using color, shape and shading in GUI icons.

At the time the invention was made, it would have been obvious to a person of ordinary skill in the art to use color, shape and shading in GUI icons to provide a graphical user interface to display different elements and features because it was well known that the use of icons of varying shape, color and shading provide a user friendly, dynamic visual presentation to an operator (abstract), therefore it would have been obvious to modify Lee as modified by Rangachari et al and Bickley et al to obtain that invention as specified in claims 8, 9, 18, 19, 25 and 26.

26. Claims 4, 7, 14, 17, 22 and 24 are rejected under 35 U.S.C. 103(a) as being unpatentable over Lee (U.S. Pat 5,616,208) in view of Rangachari et al (U.S. Pat 6,470,227) and Bickley et al (U.S. Pat 6,615,092) and further in view of Rosenthal et al (U.S. Pat 6,161,054).

Lee as modified by Rangachari et al and Bickley et al teaches a resource allocator with a graphical user interface as recited in claims 1-3, 5, 6, 10-13, 15 and 16 for the reasons above, the combination fails to teach associating information in the graphical user interface with a spreadsheet.

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Rosenthal et al teaches a graphical user interface wherein the graphical user interface presents data in a spreadsheet format (col. 5 lines 49-65).

Lee as modified by Rangachari et al and Bickley et al and Rosenthal et al are analogous art because they are both related to semiconductor manufacturing with a graphical user interface.

Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to utilize a user interface using the spreadsheet of Rosenthal et al in the resource allocator with a graphical user interface of Lee as modified by Rangachari et al and Bickley et al because it is well known that a spreadsheet can provide a large amount of information in a well organized format and Rosenthal et al teaches a significant improvements in overall equipment effectiveness, and reductions in production costs (col. 9 line 30-44).

Conclusion

27. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Hattori (U.S. Pat 6,306,740 and U.S. Pat 5,839,934), Tanabe et al (U.S. Pat 6,197,702) and Yao et al (U.S. Pat 5,746,512) – all teach the use of a vertical polysilicon furnace and a wet deck.

Alford, Jr. et al (U.S. Pub 2004/0012637) – teaches a user interface for resource allocation.

Kall et al (U.S. Pub 2003/0200130) – teaches a user interface with a queue.

Haanstra et al (U.S. Pat 6,732,006) – teaches a GUI interface for resource allocation.

Romero et al (U.S. Pat 6,256,549) – teaches a graphical user interface that allows a user to go to an excel database, excel is a well known spreadsheet.

Bermon et al (U.S. Pat 5,946,212) – teaches a graphical user interface for resource allocation.

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Chapman (U.S. Pat 5,291,394) – teaches virtual allocation of resources.

28. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Paul L Rodriguez whose telephone number is (571) 272-3753. The examiner can normally be reached on 6:00 - 4:30 T-F.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Leo P Picard can be reached on (571) 272-3749. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Paul L Rodriguez Primary Examiner Art Unit 2125

PLR 3/2/05